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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JUN 26 2008

In re the Application of: Hidehiko KIRA, et al.

Group Art Unit: 2822

Serial No.: 08/897,953

Examiner: David E. GRAYBILL

Filed: July 24, 1997

P.T.O. Confirmation No.: 5157

For: METHOD AND SYSTEM FOR FABRICATING A SEMICONDUCTOR DEVICE

AMENDMENT and PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Docket 950107A

Date June 26, 2008

Sir:

This paper is in response to the Office Action dated January 28, 2008, extended two months to June 28, 2008. This paper is a **petition for extension of time**. The Applicants hereby petition for an appropriate extension of time, and request the PTO to **charge fees** for such an extension of time and any other fees which may be due with respect to this paper to **Deposit**Account No. 01-2340.

Amendments to the Claims begin on page 2 of this paper. Remarks/Arguments begin on page 6 of this paper.